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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Christoph A. Wasshuber Art Unit: 2818  
Serial No.: 10/714,366 Examiner: Nguyen, T.  
Filing Date: 11/13/2003 Docket No.: TI-36280  
Customer No.: 23494 Conf. No.: 1864

Title: FORMING A SEMICONDUCTOR STRUCTURE IN MANUFACTURING A SEMICONDUCTOR DEVICE USING ONE OR MORE EPITAXIAL GROWTH PROCESSES

ELECTION

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8(A)  
I hereby certify that the above correspondence is being deposited with the U.S. Postal Service as first Class Mail in an envelope addressed to Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450.

12-2-05  
Date Marianna Smith  
Marianna Smith

Dear Sir:

With respect to the Restriction Requirement mailed on 11/21/2005, the Examiner has restricted the instant application to the invention of Species I (Claims 1-9, 21-23), or Species II (Claims 10-11), or Species III (Claim 24). In light of this, Applicant elects to pursue Species I, (Claims 1-9, 21-23) without traverse.

Respectfully submitted,

  
Jacqueline J. Garner  
Attorney for Applicant  
Reg. No. 36,144

Texas Instruments Incorporated  
P.O. Box 655474, M/S 3999  
Dallas, TX 75265  
(214) 532-9348 or  
(972) 917-5643  
Fax: (972) 917-4418